What Is Claimed Is:

1. A device for testing a material that changes shape when at least one of an electric field and a magnetic field is applied, comprising:

a generator for generating at least one of the electric field and the magnetic field; and at least one thermal sensor for detecting a change in temperature of the material.

2. The device according to claim 1, wherein: the material includes a piezoactive material.

3. The device according to claim 1, wherein:

the at least one thermal sensor includes a radiation detector for detecting electromagnetic radiation.

4. The device according to claim 1, wherein:

the at least one thermal sensor has a local resolution.

- 5. The device according to claim 1, further comprising:
 - an imaging unit.
- 6. The device according to claim 1, further comprising:

a unit for varying at least one of the electric field and the magnetic field.

7. The device according to claim 1, further comprising:

a unit for periodically varying at least one of the electric field and the magnetic field.

8. The device according to claim 1, wherein:

the material is arranged on a substrate.

9. The device according to claim 8, further comprising:

an arrangement for performing a temperature control of the substrate.

- The device according to claim 1, wherein:an electric contacting is arranged on the material.
- 11. The device according to claim 1, further comprising:

 a detection unit for detecting a portion of a heating of the material attributed to an electric current.
- 12. The device according to claim 11, further comprising:

 an analyzer unit for compensating a temperature increase detected by the

 at least one thermal sensor, in the material, with the portion of the heating of the material

 attributed to the electric current.
- 13. The device according to claim 8, wherein:

 at least two different test areas are provided on the substrate, the at least two different test areas including different materials.
- 14. The device according to claim 8, wherein:

 a plurality of different test areas are arranged in a grid pattern on the substrate.
- 15. The device according to claim 1, further comprising:

 a measurement unit for measuring a change in a shape of a test object.
- 16. The device according to claim 1, further comprising:

 an optical measurement unit for measuring a change in at least one of a shape and a length.